

**REPLY UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 1763**

Attorney Docket: 040258-0273851  
Client Reference: EL00018CDC

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of:  
***KOJIMA, ET AL.***

Confirmation Number: 3068

Application No.: ***09/658,501***

Group Art Unit: 1763

Filed: September 8, 2000

Examiner: Karla Moore

Title: SEMICONDUCTOR MANUFACTURING SYSTEM A VAPORIZER WHICH  
EFFICIENTLY VAPORIZES A LIQUID MATERIAL

**AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116**

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed July 26, 2007, the date for responding being  
October 26, 2007, please amend the above-identified application as follows